

DOCKET NO.: M&M-047-USA-P

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
N. YABUCHI, et al.

Serial No.: 09/988,036

#5
Art Unit: 1752

Filed: November 16, 2001

Examiner: To Be Assigned

For: Photosolder Resist Composition

INFORMATION DISCLOSURE STATEMENT
PURSUANT TO 37 C.F.R. §§ 1.56, 1.97 and 1.98

Honorable Commissioner of
Patents and Trademarks
Washington, D.C. 20231

Sir:

In compliance with the dictates of 37 C.F.R. §§ 1.56, 1.97 and 1.98, Applicants hereby submit an Information Disclosure Statement.

Applicants hereby report the issuance of a Search Report in the corresponding European application. A copy of that Search Report and the references cited therein, together with PTO Form 1449 listing each of the references is attached hereto.

CERTIFICATION PURSUANT TO 37 CFR 1.97(e)

The undersigned hereby certifies that each item of information contained herein was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement, as evidenced by the date appearing on the European Search Report which is March 18, 2002.

It is respectfully requested that the Examiner consider each of these references and indicate such consideration by enclosing an appropriately initialled copy of the enclosed form PTO-1449 with

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the next communication from the Patent Office.

Respectfully submitted,

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Date: May 10, 2002

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